Disorder effects in epitaxial thin films of (La,Ca)MnO₃

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(Received 3 March 1998; accepted for publication 3 April 1998)

We have investigated as-grown sputtered films of La_{0.7}Ca_{0.3}MnO₃ in a thickness range between 5 and 200 nm on SrTiO₃ substrates. The films are epitaxial, strained, and smooth. All films order magnetically around 175 K. Very thin films show full magnetization at low temperatures, but the temperature of the metal-insulator transition is appreciably lower than the magnetic ordering temperature. In thick films, the magnetization is much lower than expected. Both effects are probably related to structural disorder as found by transmission electron microscopy. © 1998 American Institute of Physics. [S0003-6951(98)01123-1]

The observation of "colossal" magnetoresistance (CMR) effects in thin films of manganite perovskites¹ has led to a number of investigations into their transport and magnetic properties, which were found to depend strongly on sample morphology: single crystals, polycrystals, powders, and films all have different magnetoresistance (MR) behavior. Focusing on La_{0.7}Ca_{0.3}MnO₃ (LCMO), in the metallic doping regime, measurements on annealed powders show a Curie temperature T_c of about 250 K, a peak temperature T_p of the resistance just below T_c , and only a moderate magnetoresistance ratio (MRR) of about 5 in 4 T.² These numbers can be widely different for films, due to the extreme sensitivity of the physical properties of the material to structural changes or disorder. Consequently, deposition parameters, oxygen content, but also lattice strain due to the underlying substrate, all can have an influence. Disorder and strain effects can also be influenced by postanneal procedures. Hundley et al.³ showed that with proper annealing at high temperature (950 °C) and oxygen pressure (10⁵ Pa), the values for T_c , T_p , and the MRR can become equal to the powder values quoted above. The precise morphology changes induced by the annealing are not exactly known. Among them is most probably strain relief, since the film surface usually changes from atomically smooth to rough on a scale of several nm,³ which would be due to the formation of relaxed grains. However, postannealing is often undesirable if the goal is to combine films with different physical properties (e.g., CMR and high- T_c materials), nor is it a prerequisite for producing epitaxial and smooth films.^{4,5} On the other hand, such epitaxial films usually show lower T_c 's and spreads in T_p values. Understanding the differences between films and bulk material is necessary both for applications involving heteroepitaxy (e.g., spin devices or tunnel junctions), and for elucidating the link between the microstructure and MR behavior. Especially very thin films (in the range of 10 nm) deserve attention, since they can be expected to be more uniformly strained and oxidized.

In this letter we study transport, magnetization, and film

structure for films of thickness d_s ranging from 5 to 200 nm, deposited by high-temperature oxygen sputtering on SrTiO₃ (STO) substrates at an elevated temperature. The films are epitaxial and smooth at all thicknesses, but we find major changes in their properties. First, T_c is constant around 175 K for all d_s , and T_p lies just below T_c for most thicknesses, but below 30 nm this connection is lost and T_p decreases strongly. Second, the high-field magnetization M_f has the expected value of about 3.5 μ_B/Mn for small d_s but decreases strongly with increasing thickness. Both effects point to the presence of different kinds of disorder, for which possible sources are identified by high-resolution electron microscopy (HREM).

All films were sputter deposited from ceramic targets of $La_{1-x}Ca_xMnO_3$ with a nominal composition of x=0.33 on STO substrates, in a pure oxygen atmosphere of 300 Pa, with substrate and source in line and about 2 cm apart. The high pressure causes a very low growth rate of the order of 0.9 nm/min. The growth temperature was chosen at 840 °C, in order to be able to grow high-quality films of YBa₂Cu₃O₇ under the same conditions. After deposition, each sample was cooled to room temperature without further annealing. The chemical composition of the films was determined by microprobe analysis, which showed a Ca content of x=0.27. The crystal structure was determined by x-ray diffraction and HREM; transport measurements were performed on unpatterned samples with sputtered gold contacts; and the magnetization was measured with a superconducting quantum interference device magnetometer.

Figure 1 shows typical data of resistance R and magnetization M in 0.3 T as a function of temperature T for d_s = 23 and 57 nm. As indicated, the peak in R defines T_n , while the intercept of the linearly increasing M(T) with the constant magnetization at high temperatures is used to determine T_c . Note that M(T) for $d_s = 23$ nm is larger than for 57 nm, and that for the thinner film T_p is much lower than T_c . Figure 2 shows the magnetization M_f of a typical series of films with d_s between 5 and 100 nm as a function of magnetic-field B_a at 5 K. Values for M_f were obtained by correcting the measured magnetization for the contribution of the substrate, using a susceptibility value of -1.3

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FIG. 1. (a) Magnetization *M* as a function of temperature *T* for films of 23 nm (\bigcirc) and 57 nm (+) in an applied field of 0.3 T. The arrow denotes the Curie temperatures. (b) Resistance *R* vs *T* of the same films. The arrows indicate peak temperatures T_p .

 $\times 10^{-9}~\text{m}^3/\text{kg},$ as measured on a bare substrate. In Fig. 3, different quantities are collected as a function of d_s . Figure 3(a) shows the lattice parameters b_p along the baxis, defined to be perpendicular to the substrate. They were determined from the (002) peak in a $\vartheta - 2\vartheta$ scan (indexed on a pseudocubic unit cell), compared to the equivalent STO peak with a lattice parameter of 0.3905 nm. For all samples, rocking curve widths $(\vartheta - \vartheta \operatorname{scan})$ were found to be below 0.07°. The values for $b_p \approx 0.383$ nm are significantly smaller than the bulk value of 0.386 nm. This tetragonal contraction of the unit cell, present at all d_s , is probably due to strain in the film plane, induced by epitaxial growth on the larger substrate. Strain, but also pressure, should have an effect on T_c , which is plotted in Fig. 3(b). The value of $T_c \approx 175$ K is much lower than the bulk value of 250 K, which can be either due to strain, or to the oxygen content. In polycrystalline La_{0.67}Ba_{0.33}MnO_{3- δ} decreasing δ led to serious lowering of T_c ($\Delta T_c \approx -70$ K from $\delta = 0.01$ to $\delta = 0.09$).⁶ In our films this is probably not the case. A short (15 min) postanneal at 950 °C in flowing oxygen did not show an appreciable change in T_c , although the time should be long enough to reach oxygen equilibrium.⁷ With respect to strain effects, it should be remarked that the unit cell volume is not conserved. Assuming an in-plane lattice parameter of 0.3905 nm, the volume is 5.84×10^{-2} (nm)³, compared to 5.75 $\times 10^{-2}$ (nm)³ for the bulk unit cell. The (negative) equivalent hydrostatic pressure for this volume change can be esti-



FIG. 2. Magnetization M_f as a function of applied magnetic-field B_a at 5 K, for thicknesses of 6 nm (\bigcirc), 23 nm (\triangle), 42 nm (\square), 19 nm (+), 57 nm (\diamondsuit), and 105 nm (\heartsuit). For the 19 nm film, M_f appears somewhat too low.



FIG. 3. (a) Length of the pseudocubic *b*-axis b_p as a function of film thickness d_s . The dotted line indicates the bulk value; the dashed line is meant to guide the eye. (b) Values for Curie temperature T_c (\bigcirc) and resistance peak temperature T_p as a function of d_s . (c) Magnetization $M_{f,5T}$ in 5 T at 5 K as a function of d_s . The dashed line is meant to guide the eye.

mated at 5 GPa,⁸ which could lead to $\Delta T_c \approx -20$ K,⁹ too small to explain the experimental value. However, biaxial strain can have an equal or even larger effect on T_c , as was recently argued by Millis *et al.*¹⁰ We believe, therefore, that our measured values are intrinsic for epitaxial, strained LCMO on STO, which is corroborated by similar values reported previously.^{4,5,11} Note that growth on LAO indicates different behavior, with strained, epitaxial films yielding T_c values around 240 K.¹¹

Next, we turn to the behavior of the films with small d_s . Figure 3(b) shows the values for T_p as well as for T_c , while Fig. 3(c) shows the values of M_f at 5 K in 5 T. Below about 30 nm T_p starts to decrease, while T_c remains constant and M_f is about 3.5 μ_B /Mn. In other words, magnetically the films behave as expected, but a decoupling takes place between the magnetic transition and the metal-insulator transition. Apparently, the disorder in the films is too strong at T_c to allow the formation of a metallic state, but this is overcome at lower temperature by the growing average magnetization, which favors metallic conductivity. The data also provide some coarse estimate for typical localization lengths in these films. They must be clearly larger than interatomic distances, since the ferromagnetism is due to electrons hopping with spin memory, but smaller than the film thickness of 30 nm (75 unit cells) at which T_p starts to decrease.

On increasing d_s , different behavior occurs: T_p is now close to T_c , but M_f gradually decreases from values around 3.5 μ_B /Mn for the thin films to less than 1.5 μ_B /Mn at 215 nm. Again, this must be due to some kind of disorder, which causes increasing amounts of Mn moments to be antiferromagnetically coupled. We know of no similar findings; the magnetization has not been investigated systematically, although too low values for films around 100 nm are reported routinely.^{12–14} Of course, this must have serious consequences for the transport currents. As they will not flow in antiferromagnetic regions, the current distribution in these films is probably inhomogeneous.

and 105 nm (∇) . For the 19 nm film, M_f appears somewhat too low. films is probably inhomogeneous. Downloaded 30 May 2005 to 132.229.234.112. Redistribution subject to AIP license or copyright, see http://apl.aip.org/apl/copyright.jsp



FIG. 4. HREM images for two films with different thickness d_s . (a) $d_s = 5$ nm. The specimen orientation is about 2° from the [100] zone axis of SrTiO₃ towards the [011] SrTiO₃ direction, to allow imaging of the LCMO (010) fringe. Two antiphase boundaries are visible, marked with arrows. (b) $d_s = 30$ nm. Two domain directions are clearly visible. The lower-left-hand corner shows a cubic-like structure with the *b* axis in the line of sight. The upper-middle and right-hand parts show structures with larger spacing where the *b* axis is perpendicular to the interface.

Having found different signatures for disorder, a closer look at the atomic structure is needed. Shown in Fig. 4 are two HREM images of films of 5 and 30 nm; a thick film (215 nm) was also investigated. Common to all three films is that they are epitaxial; that only few dislocations could be found, and certainly less than would be expected on the basis of a rigid body fitting of the atomic lattices of film and substrate; and that the lattice deformation imposed by the substrate persists up to the film surface. These observations confirm the conclusions from x-ray diffraction that the films are homogeneously strained and epitaxial. However, the images contain more information. In films, the crystal structure is usually referred to as pseudocubic, characterized by a single lattice parameter a_p ; small rotations of the oxygen octahedra actually lead to an orthorhombic unit cell of dimensions $\sqrt{2}a_p$, $2a_p$, $\sqrt{2}a_p$.¹⁵ This superstructure is found everywhere in the images, but there are qualitative differences between the films of 5 and 30 nm. In the 5 nm film, the baxis is always perpendicular to the interface. This is reasonable, since it is the direction of the largest mismatch. However, defects are visible in the form of antiphase boundaries (APB's), where the *b*-axis periodicity shifts over a_p (half its length). The typical APB distance is around 10 nm. In the 30 nm film, no APB's are found, but three different types of regions occur, with the three possible directions of the *b* axis. The typical size of these regions ranges from a third of d_s to three times d_s , in the 30 nm film as well as in the 215 nm film.

In short, the microstructure of films with a thickness below 30 nm is different from the microstructure found for thicker films, which offers an explanation for the differences in the behavior of T_c (constant) and T_p (decreasing). For the thicker films, the most noteworthy point is the domain type of disorder. These domains are not necessarily formed during growth. Distorted (orthorhombic) perovskites usually undergo a phase transition to a more symmetric structure at elevated temperature. For bulk LCMO, differential thermal analysis data indicate a phase transition around 500 °C,¹⁶ which makes it likely that, also in films, the structure at the growth temperature is different from the one at low temperatures. In that case, the domains could be formed during cooling of the sample. Not clear at this point is whether the domain-type disorder is responsible for the loss of magnetic moment.

The authors thank A. J. Millis, L. F. Cohen, J. A. Mydosh, and P. H. Kes for discussions. This work is part of the research program of the "Stichting voor Fundamenteel Onderzoek der Materie" (FOM), which is financially supported by NWO.

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